

09/937538

Rec'd PCT/PTO 25 SEP 2001
PATENT
Attorney Docket No: 81839.0102

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Michihiro MIZUNO

Serial No: Not assigned

Filed: September 25, 2001

For: METHOD FOR EVALUATING CONCENTRATION OF
METAL IMPURITIES IN SILICON WAFER

Art Unit: Not assigned

Examiner: Not assigned

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- ☒ patent application (36 page(s) of specification; 18 claim(s); 1 page(s) of abstract
- ☒ 2 sheet(s) of formal drawings
- ☒ executed Declaration and Power of Attorney
- ☒ assignment of the invention to SHIN-ETSU HANDOTAI CO., LTD.
- ☒ Information Disclosure Statement with 2 references
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